Electronic Acknowledgement Receipt				
EFS ID:	9304906			
Application Number:	10593857			
International Application Number:				
Confirmation Number:	5813			
Title of Invention:	PLASMA CHAMBER HAVING PLASMA SOURCE COIL AND METHOD FOR ETCHING THE WAFER USING THE SAME			
First Named Inventor/Applicant Name:	Nam Hun Kim			
Customer Number:	23363			
Filer:	Peter C. Hsueh			
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Receipt Date:	25-JAN-2011			
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Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$100
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1 Request for Certificate of Correction	58409_Req_for_Cert_of_Corr. pdf	52256	no	3	
		42d1f542101cdbbe843e699166677de26ca ff6fc			
Warnings:					
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58409 Drawing.pdf

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3 Fee Worksheet (PTO-875) fee-info.pdf

Drawings-only black and white line

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National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

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